MAY 20 2005

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

Sheet	1	of	1

Complete if Known	
Application Number	10/658,056
Filing Date	September 8, 2003
First Named Inventor	Bastos, Rui M.
Art Unit	
Examiner Name	
Attorney Docket Number	019680-003200US

U.S. PATENT DOCUMENTS+

Examiner Initials*	Cite No.[1]	Document Number — Number Kind Code[2] (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear

FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No.[1]	Foreign Patent Document — Country Code[3] Number[4] Kind Code[5] (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T[6]
						☐
						☐
						☐
						☐

NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No.[1]	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T[2]
	1	Haeberli, Paul et al. "The Accumulation Buffer: Hardware Support for High-Quality Rendering" Computer Graphics, Volume 24, Number 4, Silicon Graphics Computer Systems August 1990	
	2	Salvator, Dave " ExtremeTech 3D Pipeline Tutorial" June 13, 2001	

Examiner Signature		Date Considered	6/22/05

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.
[1] Applicant's unique citation designation number (optional). [2] Applicant is to place a check mark here if English language Translation is attached.